

Notice of References Cited	Application/Control No. 10/811,460	Applicant(s)/Patent Under Reexamination ESTKOWSKI ET AL.	
	Examiner Christine M. Behncke	Art Unit 3661	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
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FOREIGN PATENT DOCUMENTS

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	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kindel et al, Kinodynamic Motion Planning Amidst Moving Obstacles", April 2000, IEEE, Proceedings of the 2000 IEEE International Conference of Robotics & Automation, 537-543.
	V	Urmson, Approaches for Heuristically Biasing RRT Growth, October 2003, IEEE, Proceedings of the 2003 IEEE/RSJ Intl. Conference on Intelligent Robots and Systems, 1178-1183.
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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